

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akihisa HONGO *et al.*

Serial No. 10/735,771

Filed December 16, 2003



: Confirmation No. 4044

: Attorney Docket No. 2003_1822A

: Group Art Unit 1792

: Examiner Sylvia R. MacArthur

SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Mail Stop: Amendment

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action mailed January 11, 2008, the period of response thereto having been extended to May 11, 2008, please amend the above-identified application as follows: